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PATENT

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 Jennifer Bushard

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Koji TAKAHASHI and Hidenori
KAWANISHI

International Application No.: PCT/JP99/01952

International Filing Date: April 12, 1999

For: METHOD FOR FORMING
COMPOUND SEMICONDUCTOR
LAYER AND COMPOUND
SEMICONDUCTOR APPARATUS

Examiner: To Be Assigned

Group Art Unit: To Be Assigned

5 / Prel. and dt.
A
E. Willis
11-26-01

PRELIMINARY AMENDMENT

Box PCT
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The above-referenced application is being filed herewith under 35 U.S.C. §371.

Applicants wish to enter the following preliminary amendments to incorporate cross-reference to related applications.

09/786977-060701